

## IN THE U.S. PATENT AND TRADEMARK OFFICE

In re Application of:

Applicant: Atsushi Dohi

Serial No.: 09/772,325

Art Unit: 2877

Filed: January 29, 2001

Examiner: Gordon J. Stock

For: Method and Device for Measuring

Thickness of Liquid Crystal Layer

## CERTIFICATE OF MAILING UNDER 37 C.F.R. 1.8

I hereby certify that the following Amendment is being deposited with the United States Postal Service in an envelope by first class mail, postage prepaid on February 18, 2004, addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Date: 7eb 18 2004

## **AMENDMENT**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to a second, non-final Office Action mailed on November 18, 2003, please amend the above-identified application as follows: